

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of :  
Choung Hyep Lee et al. :  
Serial No. [NEW] :  
Filed: April 13, 2004 :

APPARATUS FOR AND METHOD OF HEAT-TREATING A WAFER

**INFORMATION DISCLOSURE STATEMENT**  
**(SUBMISSION IN CONTINUATION-IN-PART OR**  
**RULE 1.53(b) CONTINUATION OR DIVISIONAL APPLICATION)**

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Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications or other information submitted for consideration by the Office are listed on PTO-1449 form(s), attached hereto.

II. REFERENCES PREVIOUSLY CITED OR SUBMITTED

Pursuant to 37 C.F.R. § 1.98(d), consideration of information listed on the PTO-1449 form(s) is requested since any patents, publications or other information which are listed on the PTO-1449 form(s) but for which copies are not enclosed herewith, were previously cited by or submitted to the PTO in one of the following applications which has been relied upon for an earlier filing date under 35 U.S.C. § 120:

U.S. Serial Number  
09/605,660

U.S. Filing Date  
June 28, 2000

III. FEES

This Information Disclosure Statement is being filed within three (3) months of the filing of the present application and/or prior to the issuance of a first action on the merits; therefore, no fee is required.

If the Examiner has any questions concerning this IDS or requires a copy of any of the references cited but not provided, he/she is requested to contact the undersigned. If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule (with a petition if necessary) and charge the appropriate fee to Deposit Account No. 50-0238.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 50-0238 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional) <b>SEC.736D</b>		Application Number <b>NEW</b>
Applicant(s) <b>Choung-Hyep Kim et al.</b>		
Filing Date <b>APRIL 13, 2004</b>		Group Art Unit <b>TO BE ASSIGNED</b>

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	6,403,933 B1	06/2002	STRODTBECK et al.			
	B	5,778,969	07/1998	KYUNG et al.			
	C	2002/0096117 A1	07/2002	FUTAMURA et al.			
	D	5,981,913	11/1999	KADOMURA et al.			
	E	6,508,885 B1	01/2003	MOSLEHI et al.			
	F	6,449,871 B1	09/2002	KHOLODENKO et al.			
	G	6,185,839 B1	02/2001	KHOLODENKO et al.			

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	H	6-177141	06/24/1994	JAPAN				
	I	6-181173	06/28/1994	JAPAN				

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.